



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Gurtej S. Sandhu

Serial No.: 09/023,146

Filed: February 12, 1998

For: TUNGSTEN SILICIDE (WSIx)
DEPOSITION PROCESS FOR
SEMICONDUCTOR MANUFACTURE

Examiner: T. Dang

Group Art Unit: 2823

Attorney Docket No.: 3369.1US (91-365RE)

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Person making Deposit: Blake Johnson

AMENDMENT UNDER 37 C.F.R. § 1.114

Box RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

This Amendment is being submitted in conjunction with an RCE in response to the Final Office Action mailed June 15, 2001. Please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 48, 49, and 50, without prejudice.

A copy of the claims as they currently stand in the application follows. Please note that claims 16 through 47 are underlined because this is a reissue application.